



Docket No.: M4065.0165/P165  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Garry A. Mercaldi, et al.

Application No.: 09/285,773

Group Art Unit: 1765

Filed: April 5, 1999

Examiner: L. Eronini

For: METHOD FOR ETCHING DOPED  
POLYSILICON WITH HIGH  
SELECTIVITY TO UNDOPED  
POLYSILICON

REQUEST FOR DEFERENCE OF FIRST OFFICE ACTION

Commissioner for Patents  
Washington, DC 20231

Dear Madam:

Applicants would like to schedule an interview before the issuance of the first office action, and therefore request deference of the first office action until an interview is requested.

Dated: February 23, 2001

Respectfully submitted,

By \_\_\_\_\_  
Thomas J. D'Amico

Registration No.: 28,371  
DICKSTEIN SHAPIRO MORIN &  
OSHINSKY LLP  
2101 L Street NW  
Washington, DC 20037-1526

(202) 828-2232  
Attorneys for Applicant

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